

EAST - [067881b:1]

File View Edit Tools Window Help

Drafts

Pending

Active

L1: (4869) connect\$4 near9 line same embedded

L2: (341593) remov\$4 near9(line or block or capacit\$5 or area)

L3: (6984) contact\$3 near5 hole same(array or matri\$3)

L28: (529) (modification or modif\$4 or updat\$4)near20 contact\$3 near5 hole

L29: (56599) connect\$4 near9 line same(matri\$4 or array)

L30: (44) 128 and 129

L32: (247250) remov\$4 or delet\$4)near20(block or area

L33: (8) 132 and 130

Failed

Saved

Favorites

Tagged (2)

Find

Find

Browse

Find

Highlight all hit terms in array

132 and 130

#	U	I	Document ID	Iss	Title	Current	C
1	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030062632	20	SEMICONDUCTOR DEVICE HAVING EMBEDDED ARRAY	257/797	25
2	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20020087941	20	Semiconductor device having embedded array	716/10	25
3	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20020084457	20	Semiconductor device having embedded array	257/48	25
4	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 6555853 B2	20	Semiconductor device having embedded array	257/202	25
5	<input type="checkbox"/>	<input type="checkbox"/>	US 5994726 A	19	Field effect transistor array including refractory metal sil	257/207	25
6	<input type="checkbox"/>	<input type="checkbox"/>	US 5917211 A	19	Semiconductor integrated circuit, method of fabricating the	257/296	25
7	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 5734188 A	19	Semiconductor integrated circuit, method of fabricating the	257/401	25
8	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 5264712 A	19	Semiconductor integrated circuit, method of fabricating the	257/71	25

Ready

HTML